



PATENT  
Docket No. 740819-464

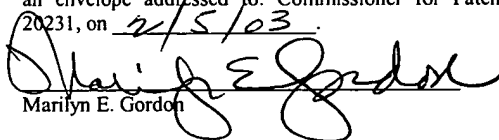
# 11/14  
2/21/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: )  
Toshiya FUKUHISA ) Group Art Unit: 2828  
Serial No. 09/717,137 ✓ ) Examiner: Jeffrey N. ZAHN  
Filed: November 22, 2000 )  
For: SEMICONDUCTOR LASER DEVICE ) Date: February 5, 2003  
AND METHOD FOR FABRICATING  
THE SAME

CERTIFICATE OF MAILING

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AMENDMENT

Honorable Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action mailed November 8, 2002, please amend the subject  
application and consider Applicant's remarks as follows:

IN THE CLAIMS:

Please cancel claim 11 without prejudice or disclaimer to the subject matter disclosed  
therein.

Please amend claim 10 as follows:

10. (Amended) A semiconductor laser device comprising:
- an etching control layer, which is formed on a first region of a compound semiconductor substrate and has a composition different from a composition of the substrate;
  - a first semiconductor laser structure, which is defined over the etching control